

Syracuse Coating Results

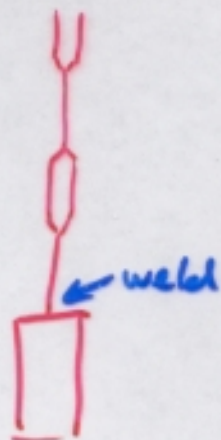
Gretarsson, Harry, Kittelberger, Penn,
Saulson, Schiller, Smith.

The measurements

- Thin Samples

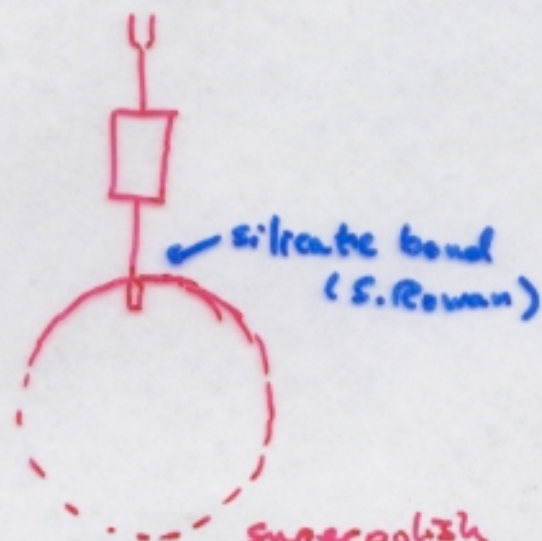
robust ✓
analytic ✓
flatness ?

2 slides



comm. polish
1mm thick
10 layer coating
2.4µm thick.

1 disk



superpolish
2cm thick
38 layer coating
24µm thick.

2.

Measure Q before & after coating

$$\phi_{\text{after}} = \phi_{\text{before}} + \left(\frac{E_{\text{coat} \parallel}}{E_{\text{tot}}} \phi_{\text{coat} \parallel} \right) + \left(\frac{E_{\text{coat} \perp}}{E_{\text{tot}}} \phi_{\text{coat} \perp} \right)$$

0 for free BC's.

calculate
 { Analytic /
 FEA

	<u>uncoated Q</u>	<u>coated Q</u> (f ~ kHz)
Slide 1	—	$(1.1 \pm 0.5, 1.6 \pm 0.1, 1.6 \pm 0.1) \times 10^5$
Slide 2	—	$(1.3 \pm 0.1) \times 10^5$
Disk	3.5×10^6	1.3×10^6

uncoated control slide Q's $(4.0 \pm 0.2, 4.9 \pm 0.2) \times 10^6$

Thinner disks being coated.

-> measure Q's soon.

3.
If innermost interface rubbing
is negligible we can
define $\phi_{\text{coat} \parallel}$ (and $\phi_{\text{coat} \perp}$)

Results:

$\phi_{\text{coat} \parallel}$
slide 1 $\Rightarrow (6.1, 4.2, 4.3) \times 10^{-4} \parallel$
slide 2 $\Rightarrow 5.1 \times 10^{-4} \parallel$
Disk $\Rightarrow 3.2 \times 10^{-4} \parallel$ (520% uncertain)

Can use $\phi_{\text{coat} \parallel}$ to estimate
 S_{th} due to coatings.

Taking $\frac{Y_{\text{coat}}}{Y_{\text{subst}}}$ into account get
estimates for both Silica & Sapphire.

4.
 Single test-mass displacement
 internal mode thermal noise:

$$S_{th}(\omega) = \frac{2 k_B T (1 - \sigma^2)}{\sqrt{\pi} \omega Y_{subst} W} \phi_{readout} \quad \left[\frac{m^2}{Hz} \right]$$

\uparrow
 Beam $\frac{1}{2}$ field width

$\phi_{readout}$ is the loss angle assoc.
 with the response to a cyclic
 Gaussian force.

$$\phi_{readout} \approx \phi_{bulk} + \frac{1}{\sqrt{\pi}} \frac{(1 - \sigma_{subst})}{(1 - 2\sigma_{subst})} \frac{d}{w} \left(\frac{Y_{coat}}{Y_{subst}} \phi_{coat \parallel} + \frac{Y_{subst}}{Y_{coat}} \phi_{coat \perp} \right)$$

\nwarrow Beam width
 \uparrow measure
 \uparrow ?!
 (ellipsometry?)

5.

Sapphire: $\frac{Y_{\text{subst}}}{Y_{\text{coat}}} \sim 36$ emphasizes $\rightarrow \phi_{\text{coat } \perp}$

Silica: $\frac{Y_{\text{subst}}}{Y_{\text{coat}}} \sim 0.7$ equal emphasis on $\rightarrow \phi_{\text{coat } \parallel}$ and $\phi_{\text{coat } \perp}$
 emphasizes $\phi_{\text{coat } \parallel}$

To estimate ϕ_{readout}

assume $\phi_{\text{coat } \parallel} = \phi_{\text{coat } \perp}$

(Not tested...)

Results for silica: (ETM, 6cm spot)
 $\phi_{\text{bulk}} = 3 \times 10^{-8}$

" Q_{readout} " $\equiv 1/\phi_{\text{readout}}$

Slide 1 $\Rightarrow (4.5, 6.6, 6.4) \times 10^6$

slide 2 $\Rightarrow 5.4 \times 10^6$

Disk $\Rightarrow 8.7 \times 10^6$

?? Likely worse for sapphire...??

Possible Solutions

- Reduce $\phi_{\text{coat} \parallel} \leftarrow \phi_{\text{coat} \perp}$
- Thinner coatings / fewer layers
- $\sqrt{S_{\text{th}}} \sim \frac{1}{W} \Rightarrow$ increase spot size
- cool the test-mass

7.
Summary:

"Smoke on the water..."